

Atty. Dkt. No. AMAT/5297/DS/M/OW/K/W

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Rivoire, et al.

Serial No.: 09/844,991

Confirmation No.: 1361

Filed: April 27, 2001

For: Method for Planarizing Organosilicate Layers

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Group Art Unit: 3723

Examiner: Robert Rose

Rose
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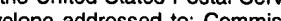
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

RESPONSE TO OFFICE ACTION DATED OCTOBER 21, 2003

In response to the Office Action dated October 21, 2003, having a shortened statutory period for response set to expire on January 21, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no fee is due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5297/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Specification are shown beginning on page 2 of this paper. **Amendments to the Claims** are shown in the listing of the claims beginning on page 3 of this paper. **Remarks/Arguments** begin on page 7 of this paper.

CERTIFICATE OF MAILING 37 CFR 1.8	
<p>I hereby certify that this correspondence is being deposited on <u>12/19</u>, 2003, with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.</p>	
<u>12/19/03</u> Date	 Signature